



Dear Prospective Meeting Participant

Thank you for your interest in participating in Accuracy in Powder Diffraction IV! This meeting is the fourth in the series which are held approximately every ten years at the National Institute of Standards and Technology (NIST). They constitute a review of the state-of-the-art in powder diffraction techniques, instrumentation and data analysis methods. The meeting will host a program of invited presentations plus a contributed poster session. APD-IV will cover the broad range of developments in powder diffraction metrology and methodology in the time since APD-III. In addition, we will host an exhibition area where leading instrument manufacturers and providers will be available to discuss recent commercial developments in the diffraction context. The meeting will betake place on the NIST campus from the 22nd to the 25th of April, 2013 in Washington, D.C.

We would be delighted to have you join us in Washington, DC. Personal invitations are not necessary to attend since the meeting is an open scientific event. The website, http://www.nist.gov/mml/apdiv_conference_2013.cfm can be viewed for updates concerning the organization of the conference.

The organizers are not able to provide financial support to meeting participants. Airfare, ground transportation, hotel, meals, travel insurance, and any other meeting-related expenses are the responsibility of the each meeting participant. Limited funding is available for students.

If you need to apply for a temporary non-immigrant visa to attend the conference, you are advised to apply for your visa as soon as possible and no later than 3-4 months in advance of the meeting date. All applicants must be able to qualify for a visa on their own merits under the requirements of the Immigration and Nationality Act. You can submit this letter with your visa application to verify the name, dates, location, and purpose of the meeting Accuracy in Powder Diffraction IV.

The organizers of APD IV are not able to call or generate personal letters to the embassy or consulate on your behalf. A registration receipt will also be generated for meeting participants.

Additional information on the visa process can be obtained from the U.S. Department of State.

We look forward to seeing you at Accuracy in Powder Diffraction IV!

Sincerely,

A handwritten signature in black ink, appearing to read 'Jim Cline', is written over a light blue horizontal line.

Jim Cline
APD-IV Conference Co-organizer